

## CALL FOR GRANT APPLICATIONS (AE2023-0496)

INESC TEC is now accepting grant applications to award 1 Research Grant (BI) within the scope of the ATE funded by IAPMEI with reference 56 Co-financed by Component 5 - Capitalization and Business Innovation, integrated in the Resilience Dimension of the Recovery and Resilience Plan within the scope of the Recovery and Resilience Mechanism (MRR) of the European Union (EU), framed in the Next Generation EU, for the period 2021 - 2026.

### 1. GRANT DESCRIPTION

**Type of grant:** Research Grant (BI)

**General scientific area:** PHYSICS,ENGINEERING

**Scientific subarea:** Optics,Electromagnetism,Electronics,Electronic engineering

**Area of Work:** Study, development and characterization of thin films applied to optical sensors

**Grant duration:** 12 months, starting on 2024-02-01, with the possibility of being renewed until the end of the project.

**Scientific advisor:** Luís Carlos Coelho

**Workplace:** INESC TEC, Porto, Portugal

**Maintenance stipend:** € 1199,64, [according to the table of monthly maintenance stipend for FCT grants](#) , paid via bank transfer. Grant holders may be awarded potential supplements, according to a quarterly evaluation process (Articles 19, 21 and 22 of the [Regulations for Grants of INESC TEC](#) and Annex II), up to a maximum limit of 50% of the monthly maintenance stipend.

INESC TEC supports costs with registration, enrolment or tuition fees, during the grant duration, under the terms established in the internal document: "[Payment of Tuition fees to grant holders](#)".

The grant holder will benefit from health insurance, supported by INESC TEC.

### 2. OBJECTIVES:

Assembly and optimization of a high vacuum line with a thin film deposition system using RF Sputtering for the manufacture of 1-dimensional structures.

Installation and programming of an automatic control unit for thin film deposition.

Simulation of the optical properties of nanostructures for the excitation of surface electromagnetic waves.

Manufacture of optical structures based on surface electromagnetic waves applied to sensing.

### 3. BRIEF PRESENTATION OF THE WORK PROGRAMME AND TRAINING:

This scholarship will be carried out within the scope of a project that aims to develop and implement optical sensors in an industrial context. They will be applied to detect gas leaks in the energy sector and monitor water quality in the environmental area.

It is intended that the scholarship holder will develop simulation models of nanostructures for the propagation of surface waves and carry out experimental validation through fabrication and subsequent optical characterization.

#### 4. REQUIRED PROFILE:

##### Admission requirements:

Master's degree in Physics Engineering

The awarding of the fellowship is dependent on the applicants' enrolment in study cycle or non-award courses of Higher Education Institutions.

##### Preference factors:

Practice in experimental work with optical systems using optical fiber.

Experience in manufacturing multi-layer structures.

Experience in design and 3D printing for the development of prototypes.

##### Minimum requirements:

Advanced knowledge of surface wave simulation in optical systems.

Experience in thin film deposition using techniques such as RF Sputtering and Electron Beam Thermal Evaporation

#### 5. EVALUATION OF APPLICATIONS AND SELECTION PROCESS:

**Selection criteria and corresponding valuation:** the first phase comprises the Academic Evaluation (AC), based on the criteria referred to in Article 12 of the [Regulations for Grants of INESC TEC](#), while the second phase comprehends the Individual Interview (EI). All factors are evaluated on a scale of 0 to 100, taking into account the applicants' merit, suitability and conformity with the preference factors.

The weight of the AC factors are as follows: Academic Qualifications (FA, 50%), Scientific Publications (PC, 10%), Experience (EX, 20%) and Motivation Letter (CM, 20%).

Candidates who score less than 50 points in the AC average will be considered excluded on absolute merit. The top five candidates approved on absolute merit will be qualified for the individual interview. The Final Grade (CF) is obtained by the weighted average of AC (70%) and EI (30%).

##### The Selection Jury is composed of the following members:

President of the Jury: Luís Carlos Coelho

Full member: José Almeida

Full member: João Pedro Mendes

Substitute member:

**Release of results and prior hearing:** the results of the selection process, as well as the terms and procedures for prior hearing, will be released to the applicants by email, under the terms referred to in Article 13 of the Regulations for Studentships and Fellowships of INESC TEC.

#### 6. FORMALISATION OF APPLICATIONS:

##### Application Documents:

1. Motivation letter;
2. Curriculum Vitae (must include the list of previous fellowships, their type, beginning and end dates, funding entities and host institutions);
3. Certificate or diploma degree;
4. Proof of enrollment in a degree awarding study cycle or in a non degree awarding Higher Education program.
  - The proof of enrollment may be presented just during the grant hiring stage.
5. Signed declaration stating the infringement of the grant holder's duties (article 14, no. 4)
6. Documental evidence to support the country of residence, residence permit or other legally equivalent document, in cases where the applicant is a foreigner or non-resident in Portugal - valid until the beginning of the grant.
7. Other supporting documents relevant to the final assessment.

Failure to deliver the required documents within the 90-day period after the date of the notice of the conditional awarding of the grant implies its cancellation.

**Application period:** From 2023-12-21 to 2024-01-05

**Submission of applications:** the application will be formalised by submitting the form available in the *Work With Us* section of INESC TEC website.

## 7. BINDING LEGISLATION AND REGULATION

The hiring process shall comply with the current legislation regarding the Research Grant Holder Statute, approved by Law no. 40/2004 of August 18, in its current wording, as well as by the [Regulations for Grants of INESC TEC](#) and for [FCT Grants Regulation in force](#).

For more information, please check the [Regulations for Grants of INESC TEC](#) and relevant annexes at [www.inesctec.pt/bolsas](http://www.inesctec.pt/bolsas)

